

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/670,425	LIU ET AL.
Examiner	Art Unit	
Dennis L. Vautrot	2167	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
707	104	10/25/2006	DV
707	10	10/25/2006	DV
.			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Updated EAST search	10/26/2006	DV
ACM Portal	10/25/2006	DV
IEEE Expolore	10/25/2006	DV
Google	10/25/2006	DV
INSPEC	10/25/2006	DV
consult with and case reviewed by Kuen S. Lu, Patent Examiner, Art Unit 2167	10/25/2006	DV
consult with Luke Wassum for search help, Primary Examiner Art Unit 2167	10/25/2006	DV
consult with and case reviewed by John Cottingham, SPE Art Unit 2167	10/30/2006	DV